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SECTION 2. FORMS PTO/SB/08A and 08B (formerly Form PTO-1449)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE TECHNOLOGY CENTER R3700

Applicants: Novotny et al. Attorney Docket: 2442/120
Serial No: 09/995,362 Art Group Unit: ~~3743~~ 3753
Date Filed: November 27, 2001 Examiner Name: ~~Not yet assigned~~ CIRIC
Invention: Method and System for Cooling Electronic Components

LIST OF PATENTS AND PUBLICATIONS FOR
APPLICANT'S SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

U.S. PATENT DOCUMENTS					
Examiner Initials	Reference Number	Document Number	Issue Date	Inventor	Class/Subclass
LVC	AK	US 4,729,424	Mar. 8, 1988	Mizuno et al.	165/30
LVC	AL	US 5,406,807	Apr. 18, 1995	Ashiwake et al.	62/376
LVC	AM	US 6,438,984	Aug. 27, 2002	Novotny et al.	62/259.2
LVC	AN	US 6,587,343	Jul. 1, 2003	Novotny et al.	361/698

Examiner Signature: LVCiricDate Considered: October 15, 2003

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation *if not* in conformance and not considered. Include copy of this form with next communication to applicant.



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<u>LVC</u>	AA	4,729,424	04/08/88	<u>Mizuno et al.</u> Toukasa et al. fvc 10-14-03	165/30
<u>LVC</u>	AB	5,183,104	02/02/93	Novotny	165/104.33
<u>LVC</u>	AC	5,535,094	07/09/96	Nelson et al.	361/697
<u>LVC</u>	AD	5,706,668	01/13/98	Hilpert	62/259.2
<u>LVC</u>	AE	5,912,802	06/15/99	Nelson	361/695
<u>LVC</u>	AF	6,029,742	02/29/00	Burward-Hoy	165/80.4
<u>LVC</u>	AG	6,050,327	04/18/00	Gates	165/80.3
<u>LVC</u>	AH	6,205,796 B1	03/27/01	Chu et al.	62/94
<u>LVC</u>	AI	6,205,803 B1	03/27/01	Scaringe	62/259.2
<u>LVC</u>	AJ	6,213,194 B1	04/10/01	Chrysler et al.	165/80.3

Examiner Signature: LVC

Date Considered: October 14, 2003

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if *not* in conformance and not considered. Include copy of this form with next communication to applicant.

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